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IN THE UNITED STATES  
PATENT AND TRADEMARK OFFICE

**PATENT APPLICATION**

Applicant: **Seutter et al.**

Case: **AMAT/5192/ISM/CORE MCVD/SB**

Serial No.: **09/776,329**

Filed: **February 2, 2001**

Examiner: **Toniae M. Thomas** Group Art Unit: **2822**

Title: **FORMATION OF A TANTALUM-NITRIDE LAYER**

Mail Stop Non-Fee Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**FAX RECEIVED**

**MAY 02 2003**

**TECHNOLOGY CENTER 2800**

**S I R:**

**AMENDMENT**

In response to the Office Action dated February 4, 2003 (Paper No. 7),  
please amend the above-identified application as indicated..